



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No. : 10/530341 Confirmation No. N/A  
 Applicant : Yoshiyuki Nakamizo et al.  
 Filed : April 1, 2005  
 TC/A.U. : N/A  
 Examiner : N/A  
  
 Title : SEMICONDUCTOR ACCELERATION SENSOR AND  
 PROCESS FOR MANUFACTURING THE SAME  
 Docket No. : NIS-16035  
 Customer No. : 040854

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir/Madam:

In accordance with Rule 56, applicant is aware of the publications listed in the International Search Report (Copy enclosed) and in the enclosed copy of Patent Office Form PTO/SB/08A. A copy of each of the publications is enclosed herewith.

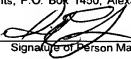
Respectfully submitted,

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